

CH 2811
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Laws
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Daniel G. Schweikert, John F. MacDonald
Assignee: Sun Microsystems, Inc.
Title: METAL REGION FOR REDUCTION OF CAPACITIVE COUPLING
BETWEEN SIGNAL LINES
Serial No.: 09/452,367 Filed: November 30, 1999
Examiner: Unknown Group Art 2811
Unit:
Docket No.: P-3790



Monterey, CA
January 27, 2000

ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT RECEIVED
UNDER §1.97 (b)

FEB 04 2000

TECHNOLOGY CENTER 2800

Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicants wish to call the following documents (a copy of each is enclosed) to the attention of the Examiner.

U.S. PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME
1)	5,321,283	June 14, 1994	Cogan et al.
2)	5,854,503	December 29, 1998	Hsueh et al.
3)	5,994,765	November 30, 1999	Mitra et al.

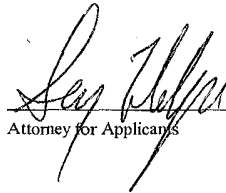
A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

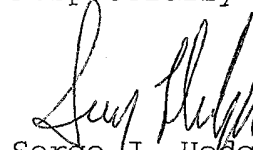
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

Jan. 27, 20 00


Attorney for Applicants

Jan. 27, 2000
Date of Signature

Respectfully submitted,


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